



Gp 2851

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#14/D  
1-27-03  
JPR

In re the Application of

Kazuya OTA et al.

Group Art Unit: 2851

Application No.: 09/846,304

Examiner: K. Brown

Filed: May 2, 2001

Docket No.: 104313.01

For: APPARATUS AND METHOD FOR PATTERN EXPOSURE AND  
METHOD FOR ADJUSTING THE APPARATUS

SUPPLEMENTAL AMENDMENT

Director of the U.S. Patent and Trademark Office

Washington, D.C. 20231

Sir:

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TECHNOLOGY CENTER 2800

Further to the Amendment under 37 C.F.R. §1.111 filed on December 17, 2002,  
please further amend the above-identified application as follows:

IN THE CLAIMS:

Please replace claims 1, 23-25, 31, 42 and 43 as follows:

The following is a marked-up version of the amended claims:

1. (Twice Amended) A method for performing an optical adjustment on an exposure apparatus which exposes an object with exposure light from a light source, comprising:
- generating, from said light source, non-exposure light having a wavelength which is different from that of said exposure light, said non-exposure light including at least one of ultraviolet light and visible light;
- adjusting an optical property of an optical system through which said exposure light passes by receiving said non-exposure light from said light source through at least a part

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